

<b>Notice of References Cited</b>	Application/Control No. 10/560,584		Applicant(s)/Patent Under Reexamination TASHIRO ET AL.	
	Examiner ANN Y. LAM		Art Unit 1641	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,195,872	03-2007	Agrawal et al.	435/6
*	B	US-2004/0028875	02-2004	Van Rijn et al.	428/98
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

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